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Stylesheet Version v1.1.0

Title of Invention	SPUTTERING APPARATUS AND MANUFACTURING METHOD OF METAL LAYER/METAL COMPOUND LAYER BY USING THEREOF	
Application Number :		
Date :		
First Named Applicant:	Mr. Yu-Cheng Liu	
Confirmation Number:		
Attorney Docket Number:	10683-US-PA-1	
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Submitted By:		Elec. Sign.
Dr. Belinda Lee Registered Number: 46,863		/Belinda Lee/ Sign. Capacity Agent

Documents being submitted:	Files
us-request	10683-D-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	10683-D-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
application-body	10683Dusf.xml application-body.dtd Image1.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl wipo.ent
application-body-pdf-wrap	10683Dusf-pdf-wrap.xml
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drawings-pdf	10683Dusf-draw.pdf
us-declaration	10683declaration1.tif
us-declaration	10683declaration2.tif
Comments Please be kindly advised that the indicated fee of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fee in connection with this application to Deposit Account No. 50-2620(Order No. 10683-US-PA-1). Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda	

